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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Miwa WAKE et al. :  
Serial No. 10/766,587 : Group Art Unit: 2822  
Filed: January 28, 2004 : Examiner: Thanh Y. Tran  
For: METHOD OF MANUFACTURING :  
A SEMICONDUCTOR :  
INTEGRATED CIRCUIT AND :  
SEMICONDUCTOR INTEGRATED :  
CIRCUIT : Docket No. S004-4839 (DIV)

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Mail Stop Amendment  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE

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In response to the Office Action dated September 19, 2005, applicants amend their application as follows:

ADDITIONAL FEE:

No additional fees are believed required in connection with this response; however, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

MAILING CERTIFICATE ON PAGE 23